

# Cypress Semiconductor Qualification Report

QTP# 97253, VERSION 2.0  
July, 2003

| <b>1 Meg SRAM, R28 Technology, Fab 4 Qualification</b> |                            |
|--|----------------------------|
| <b>CY7C106A</b>  | <b>256K x 4 Static RAM</b> |
| <b>CY7C109</b>   | <b>128K x 8 Static RAM</b> |

## **CYPRESS TECHNICAL CONTACT FOR QUALIFICATION DATA:**

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**PRODUCT/TECHNOLOGY/FAB DESCRIPTION**

| <b>PRODUCT DESCRIPTION (for qualification)</b>   |  |
|--|--|
| Information provided in this document is intended for generic qualification and technically describes the Cypress part supplied: |  |
| Marketing Part #:  | CY7C106A/CY7C109                                 |
| Package:   | 32-pin, 400 mil SOJ                              |
| Device Description:  | 1 Meg SRAM, R28 Technology                       |
| Cypress Division:  | Cypress Semiconductor Corporation - MPD Division |
| Overall Die (or Mask) REV Level (pre-requisite for qualification):   | Rev. F   |
| What ID markings on Die:   | 7C109AC  |

| <b>TECHNOLOGY/FAB PROCESS DESCRIPTION - R28</b>   |   |                    |   |
|---|---|--------------------|---|
| Number of Metal Layers:                           | 2   | Metal Composition: | Metal 1: Ti/TiW/Al-Si/TiW, 500A/1.2KA/6KA/1.2KA<br>Metal 2: TiW/Al-Si/Ti, 1.2KA/10KA/150A |
| Passivation Type and Materials:                   | 7,000A TEOS + 6,000A Si <sub>2</sub> N <sub>4</sub> |                    |   |
| Free Phosphorus contents in top glass layer(%):   | 0%  |                    |   |
| Die Coating(s), if used:                          | n/a   |                    |   |
| Number of Transistors in device:                  | 4,200,00  |                    |   |
| Number of Gates in device:                        | 1,100,00  |                    |   |
| Generic Process Technology/Design Rule (μ-drawn): | CMOS, Single Poly, Double Metal /0.65 μm            |                    |   |
| Gate Oxide Material/Thickness (MOS):              | SiO <sub>2</sub> / 165 Å                            |                    |   |
| Name/Location of Die Fab (prime) Facility:        | Cypress Semiconductor - Bloomington, MN             |                    |   |
| Die Fab Line ID/Wafer Process ID:                 | Fab4/R28  |                    |   |

**PLASTIC PACKAGE/ASSEMBLY DESCRIPTION**

|  |                             |                      |                    |
|--|-----------------------------|----------------------|--------------------|
| Package Outline, Type, or Name:        | 32-pin, 400-mil SOJ         |                      |                    |
| Mold Compound Name/Manufacturer:       | NITO MP-8000CHV             |                      |                    |
| Lead Frame material:                   | Copper                      |                      |                    |
| Lead Finish, composition:              | Solder Plated, 85%Sn, 15%Pb |                      |                    |
| Die Attach Area Plating:               | Silver Spot                 |                      |                    |
| Die Attach Method:                     | Epoxy                       | Die Attach Material: | Ablestik 84-1MISR4 |
| Wire Bond Method:                      | Thermosonic                 | Wire Material/Size:  | Gold / 1.3 mil     |
| JESD22-A112 Moisture Sensitivity Level | Level 1                     |                      |                    |
| Assembly Line ID and Process ID:       | Omedata, Indonesia          |                      |                    |

**Note:** Please contact a Cypress Representative for other packages availability.

**RELIABILITY TESTS PERFORMED**

| Stress/Test  | Test Condition<br>(Temp/Bias)  | Result<br>P/F |
|--|--|---------------|
| High Temperature Operating Life<br>Latent Failure Rate   | Dynamic Operating Condition, Vcc = 5.75V, 150°C  | P             |
| Read and Record Life Test                                | Dynamic Operating Condition, Vcc = 5.75V, 150°C  | P             |
| High Temperature Steady State Life                       | Static Operating Condition, Vcc = 5.75V, 150°C   | P             |
| High Accelerated Saturation Test<br>(HAST)               | 140°C, 85%RH, 5.5V<br>Precondition: JESD22 Moisture Sensitivity Level 1<br>168 Hrs. 85°C/85%RH                                     | P             |
| Temperature Cycle  | MIL-STD-883C, Method 1010, Condition C, -65°C to 150°C<br>Precondition: JESD22 Moisture Sensitivity Level 1<br>168 Hrs. 85°C/85%RH | P             |
| Electrostatic Discharge<br>Human Body Model (ESD-HBM)    | 2,200V<br>MIL-STD-883, Method 3015.7   | P             |
| Electrostatic Discharge<br>Charge Device Model (ESD-CDM) | 1,500V<br>Cypress Spec. 25-00020   | P             |
| Latchup Sensitivity                                      | 9.5V<br>In accordance with JEDEC 17. Cypress Spec. 01-00081  | P             |

**RELIABILITY FAILURE RATE SUMMARY**

| Stress/Test  | Device Tested/<br>Devive Hours | #<br>Fail | Activation<br>Energy | Thermal<br>AF | Failure Rate |
|--|--------------------------------|-----------|----------------------|---------------|--------------|
| High Temperature Operating Life <sup>1</sup> ,<br>Early Failure Rate         | N/A                            | N/A       | N/A                  | N/A           | N/A          |
| High Temperature Operating Life <sup>2,3,4</sup> ,<br>Long Term Failure Rate | 366,500 DHRs                   | 0         | 0.7                  | 170           | 15 FIT       |

<sup>1</sup> Early Failure Rate was not performed. Production burn-in at 62 Hrs/6.5V/150°C is performed for CY7C106A and CY7C109 frabricated in Fab 4.

<sup>2</sup> Assuming an ambient temperature of 55°C and a junction temperature rise of 15°C.

<sup>3</sup> Fit Rate was calculated for 1 Meg SRAM, Rev. E, R28 technology qualified in fab 3 (QTP 96313) and fab 4 (QTP 97253).

<sup>4</sup> Chi-squared 60% estimations used to calculate the failure rate.

$$AF = \exp \left[ \frac{E_A}{k} \left[ \frac{1}{T_2} - \frac{1}{T_1} \right] \right]$$

where:

$E_A$  =The Activation Energy of the defect mechanism.

$k$  = Boltzmann's constant =  $8.62 \times 10^{-5}$  eV/Kelvin.

$T_1$  is the junction temperature of the device under stress and  $T_2$  is the junction temperature of the device at use conditions.

**RELIABILITY TEST DATA**

**QTP #: 97253<sup>1</sup>**

| DEVICE   | ASSY-LOC | FABLOT# | ASSYLOT#  | DURATION | S/S | REJ | FAIL MODE |
|--|----------|---------|-----------|----------|-----|-----|-----------|
| <b>STRESS: ESD-CHARGE DEVICE MODEL (1500V)</b>   |          |         |           |          |     |     |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | COMP     | 3   | 0   |           |
| <b>STRESS: ESD-HUMAN BODY CIRCUIT PER MIL STD 883, METHOD 3015 (2200V)</b>             |          |         |           |          |     |     |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | COMP     | 3   | 0   |           |
| <b>STRESS: HI-ACCEL SATURATION TEST (140C,85%RH, 5.5V), PRECOND. 168 HRS 85C/85%RH</b> |          |         |           |          |     |     |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | 128      | 48  | 0   |           |
| <b>STRESS: HIGH TEMP STEADY STATE LIFE TEST (150C, 5.75V)</b>                          |          |         |           |          |     |     |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | 80       | 80  | 0   |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | 168      | 80  | 0   |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615485 | 80       | 80  | 0   |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615485 | 168      | 80  | 0   |           |
| <b>STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-LATENT FAILURE RATE (150C, 5.75V)</b>      |          |         |           |          |     |     |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615486 | 80       | 260 | 0   |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615486 | 500      | 259 | 0   |           |
| <b>STRESS: READ &amp; RECORD LIFE TEST (150C, 5.75V)</b>                               |          |         |           |          |     |     |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | 500      | 10  | 0   |           |
| <b>STRESS: TEMPERATURE CYCLE COND. C, -65 TO 150C, PRECOND. 168 HRS 85C/85%RH</b>      |          |         |           |          |     |     |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | 300      | 48  | 0   |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615484 | 1000     | 48  | 0   |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615485 | 300      | 48  | 0   |           |
| CY7C109-VC   | INDNS-O  | 4646419 | 519615487 | 300      | 48  | 0   |           |

<sup>1</sup> QTP #97253, 1Meg SRAM, Rev. F, R28 technology, Fab 4 qualification.

**DEVICE RELATED RELIABILITY TEST DATA**

**QTP #: 96313<sup>2</sup>**

| DEVICE  | ASSY-LOC | FABLOT# | ASSYLOT#  | DURATION | S/S | REJ | FAIL MODE |
|---|----------|---------|-----------|----------|-----|-----|-----------|
| <b>STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-EARLY FAILURE RATE (150C, 5.75V)</b>        |          |         |           |          |     |     |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 48       | 510 | 0   |           |
| CY7C109-VC  | INDNS-O  | 3631357 | 519610871 | 48       | 510 | 0   |           |
| CY7C109-VC  | INDNS-O  | 3630218 | 519610893 | 48       | 510 | 0   |           |
| <b>STRESS: HI-ACCEL SATURATION TEST (140C, 85%RH, 5.5V), PRECOND. 168 HRS 85C/85%RH</b> |          |         |           |          |     |     |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 128      | 48  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3630218 | 519610893 | 128      | 48  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3632497 | 519611457 | 128      | 48  | 0   |           |
| <b>STRESS: HIGH TEMP STEADY STATE LIFE TEST (150C, 5.75V)</b>                           |          |         |           |          |     |     |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 80       | 80  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 168      | 80  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3631357 | 519610871 | 80       | 80  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3631357 | 519610871 | 168      | 80  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3630218 | 519610893 | 80       | 80  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3630218 | 519610893 | 168      | 77  | 0   |           |
| <b>STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-LATENT FAILURE RATE (150C, 5.75V)</b>       |          |         |           |          |     |     |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 80       | 118 | 0   |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 500      | 118 | 0   |           |
| CY7C109-VC  | INDNS-O  | 3631357 | 519610871 | 500      | 120 | 0   |           |
| CY7C109-VC  | INDNS-O  | 3630218 | 519610893 | 500      | 120 | 0   |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 1000     | 118 | 0   |           |
| <b>STRESS: READ &amp; RECORD LIFE TEST (150C, 5.75V)</b>                                |          |         |           |          |     |     |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 48       | 10  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 500      | 10  | 0   |           |
| <b>STRESS: TC COND. C, -65 TO 150C, PRECOND. 168 HRS 85C/85%RH</b>                      |          |         |           |          |     |     |           |
| CY7C109-VC  | INDNS-O  | 3627860 | 519610489 | 300      | 48  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3630218 | 519610893 | 300      | 48  | 0   |           |
| CY7C109-VC  | INDNS-O  | 3632497 | 519611457 | 300      | 48  | 0   |           |

<sup>2</sup> QTP #96313, 1Meg SRAM, Rev. F, R28 technology, Fab 3 qualification.